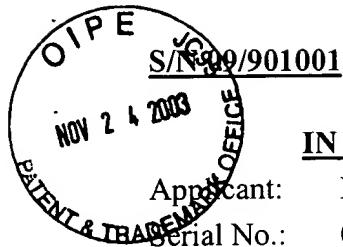


**EXPEDITED PROCEDURE – EXAMINING GROUP 1756**



**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Kie Y. Ahn et al. Examiner: Kathleen Duda  
Serial No.: 09/901001 Group Art Unit: 1756  
Filed: July 9, 2001 Docket No.: 1303.016US1  
Title: COPPER ELECTROLESS DEPOSITION TECHNOLOGY FOR ULSI  
METALIZATION

RECEIVED  
DEC 01 2003  
TC 1700

**RESPONSE UNDER 37 C.F.R. 1.116**

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

This paper is filed in response to the final Office Action mailed September 25, 2003.